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Technology and Culture (ISSN 0040-165X) is published quarterly, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, 1 year, \$35.00, 2 years \$63.00; individuals, 1 year \$25.00. Student rate (U.S.A.): 1 year, \$18.00 (letter from professor must accompany subscription). Single copies: institutions \$8.50, individuals \$6.00. Back issues are available from 1966 (vol. 7). Subscriptions include membership in the Society for the History of Technology. Checks should be made payable to The University of Chicago Press, Journals Division, P.O. Box 37005, Chicago, Illinois 60637; all business correspondence, including changes of address (old as well as new address), should be sent to that address.

Volumes 1-6 available from Kraus Reprints, Route 110, Millwood, New York 10546. All volumes are available in microfilm from University Microfilms, 300 North Zeeb Road, Ann Arbor, Michigan 48106; in microfiche from Johnson Associates, Box 1017, Greenwich, Connecticut 06830, and J.S. Canner & Co., 49-65 Lansdowne Street, Boston, Massachusetts 02215.

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Editorial office sponsored by National Museum of American History, Roger G. Kennedy, director.

Published by The University of Chicago Press, Chicago, Illinois 60637; The University of Chicago Press Ltd., London W.C. 1. Second-class postage for *Technology and Culture* paid at Chicago.

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